



App. Docket No. 42390.P7068
Confirmation No. 7737

PATENT

25/6/03
7-10-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:

Peng Cheng, et al.

Application No.: 09/343,293

Filed: June 30, 1999

For: TRANSISTOR STRUCTURE
HAVING SILICIDE SOURCE/DRAIN
EXTENSIONS

Examiner: Edgardo Ortiz

Art Unit: 2815

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on June 24, 2003

Date

Beverly Kehoe Shea
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Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**PETITION FOR EXTENSION OF TIME
PURSUANT TO 37 C.F.R. § 1.136 (a)**

Sir:

Applicant respectfully petitions pursuant to 37 CFR 1.136(a) for a one month extension of time to file this response to the Office Action mailed March 19, 2003. The extended period is set to expire on July 19, 2003. A check in the amount of \$110.00 is enclosed to cover the fee for a one month extension of time.

Please charge any shortages and credit any overages to our Deposit

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Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Dated: June 24, 2003

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